


I & C TC Taiwan Chapter Staff Report

April 8, 2016

SEMI Taiwan Staff Report [1/4]

SEMI Global 2016 Calendar of Events

Event Name		Event Details
	SEMICON Korea	January 27-29, 2016 Seoul, Korea
	Solarcon China SEMICON China	March 15-17, 2016 Shanghai, China
	SEMICON Russia	8-9 June, 2016 Moscow, Russia
	SEMICON Southeast Asia	26 - 28 Apr, 2016 Penang, Malaysia
	Advanced Semiconductor Manufacturing Conference	May 16-19, 2016 Saratoga Spring, NY
	SEMICON West	July 12-14, 2016 San Francisco, California
	SEMICON Taiwan	September 7-9, 2016 Taipei, Taiwan
	SEMICON Europa	October 25-27, 2016 Grenoble, France
	SEMICON Japan	December 14-16, Tokyo, Japan

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2016 Critical Dates for SEMI Standards Ballots

Cycle	Ballot Submission Date	Voting Period Starts	Voting Period Ends
1	January 4	January 12	February 12
2	February 2	February 16	March 17
3	March 1	March 14	April 13
4	April 15	April 26	May 26
5	May 10	May 24	June 23
6	July 22	August 1	September 1
7	August 17	August 31	September 30
8	October 17	October 24	November 23
9	November 16	November 30	December 30



http://www.semi.org/en/Standards/P_000788

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- SEMI Standards ballots are available for review at <http://ams.semi.org/ebusiness/standards/ballots.aspx>
- SEMI I&C Korea TC chapter meeting will be held on April 29.
- SEMI I&C Japan TC chapter meeting will be held on June 16.
- JA GEM300 TF co-leader Mr. Yoshihisa Takasaki provided the latest revision of document #5601A Wafer Job Management, which is going to be submitted for SEMI Cycle 4 ballot and asked TF members' comment for review.

2016 SEMI Training course topics:

- 3/21 : EHS and Sustainable Manufacturing Seminar (completed)
- 3/30 : Learn the Importance of Disaster Recovery from Ten-Billion Loss. (completed)
- 5/4 : Introduction of Water footprint
- 6/15 : Semiconductor Tool and Parts Decontamination - Decommission (Basic)
- 9/23 : Semiconductor Tool and Parts Decontamination – Team-based and Practice-based Learning (Advanced)